

J4902 U.S. PTO
09/325951
06/04/99

Sir:

Transmitted herewith for filing is the Patent Application of:

Inventor: MIN-HSIUNG CHIANG, JIN-YUAN LEE AND JENN MING HUANG

For: METHOD FOR FORMING HIGH PURITY SILICON OXIDE FIELD OXIDE ISOLATION REGION

JC586 U.S. PTO



Enclosed are:

06/04/99

- ☒ 1 sheets of drawing(s) - formal.
- ☒ An assignment of the invention to Taiwan Semiconductor Manufacturing Company
- ☐ An associate power of attorney

The filing fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	OTHER THAN A SMALL ENTITY	
FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 760.
TOTAL CLAIMS	10 -20=	0	x 18 =	\$ 0.
INDEP CLAIMS	2 -3=	0	x 78 =	\$ 0.
MULTIPLE DEPENDENT CLAIM PRESENTED			+ 260 =	
			SUB TOTAL	\$ 760.
			ASSIGNMENT	\$40.
			TOTAL	\$ 800.

- ☒ Please charge my Deposit Account No. 19-0033 in the amount of \$ 800. A duplicate copy of this sheet is enclosed.
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- ☒ Any additional filing fees required under 37 CFR \$1.16.
- ☒ Any patent application processing fees under 37 CFR \$1.17.

Respectfully submitted,
Stephen B. Ackerman
STEPHEN B. ACKERMAN, REG. NO. 37,761

SERIAL NUMBER	FILING DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
09/325,951	06/04/99	438	2812	TSMC98-262

APPLICANT MIN-HSIUNG CHIANG, TAIPEI, TAIWAN; JIN-YUAN LEE, HSIN-CHU, TAIWAN;
JENN-MING HUANG, HSIN-CHU, TAIWAN.

****CONTINUING DOMESTIC DATA*******

VERIFIED

RP None

****371 (NAT'L STAGE) DATA*******

VERIFIED

RP None

****FOREIGN APPLICATIONS*******

VERIFIED

RP None

IF REQUIRED, FOREIGN FILING LICENSE GRANTED 06/30/99

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY TWX	SHEETS DRAWING 1	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 2
Verified and Acknowledged <u>RP</u> Examiner's Initials _____ Initials _____						

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TITLE METHOD FOR FORMING HIGH PURITY SILICON OXIDE FIELD OXIDE ISOLATION
REGION

FILING FEE
RECEIVED

\$760

FEES: Authority has been given in Paper
No. _____ to charge/credit DEPOSIT ACCOUNT
NO. _____ for the following:

- ☐ All Fees
☐ 1.16 Fees (Filing)
☐ 1.17 Fees (Processing Ext. of tim)
☐ 1.18 Fees (Issue)
☐ Other _____
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